

Electronic Patent Application Fee Transmittal

Application Number:	09742386			
Filing Date:	22-Dec-2000			
Title of Invention:	Apparatus and method for processing semiconductor substrate			
First Named Inventor/Applicant Name:	Norio Kimura			
Filer:	Nils Erik .Pedersen/Karen Gass			
Attorney Docket Number:	2000-1761A			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Request for continued examination	1801	1	810	810
Total in USD (\$)				810